Additively manufactured ultra-high vacuum chamber below $10^{-10}$ mbar

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Metal-based additive manufacturing (AM) represents a paradigm change in engineering and production methods across multiple industries and sectors. AM methods enable mass reduction and performance optimisation well beyond that achievable via conventional manufacturing, thereby impacting significantly on aerospace and space technologies [1, 2]. Technologies relying on high and ultra-high vacuum (UHV), such as x-ray photo-electron spectroscopy, photo-sensors, cameras and cryostats, could also benefit greatly from AM. Despite recent advances in AM processing of metals [3, 4], additively manufactured UHV chambers have so far not been achieved. Reducing the mass of UHV equipment is particularly critical for the development of portable cold atom systems, which are expected to underpin the next generation of sensing and timekeeping technologies [5] and to allow novel space-based sensors for fundamental research [6, 7].

We demonstrate here an additively manufactured UHV chamber reaching a pressure below $10^{-10}$ mbar, enabling a cloud of cold $^85\text{Rb}$ atoms to be trapped - the starting point for many precision timekeeping and sensing devices [5]. The chamber is manufactured from aluminium alloy AlSi10Mg by laser powder bed fusion [8] and has a mass of less than a third of a commercially-available equivalent. Outgassing analysis based on mass spectrometry was performed and it was demonstrated that even without active pumping the system remains in the $10^{-9}$ mbar regime for up to 48 hours.

Additive manufacturing allows components to be designed for optimal performance, without the constraint of traditional manufacturing considerations. This approach, known as “design for AM” [8], is ideal for the production of custom parts and complex geometries. It also permits mass reduction via latticing, elimination of extraneous material and part consolidation. Applying this approach to a full vacuum apparatus could yield significant reductions in the size, weight and development lead time of UHV systems. This will facilitate both fundamental research and technological development across a range of disciplines, including the area of portable quantum technologies and quantum experiments in space based on ultracold atoms.

Systems involving laser cooled atoms in a UHV environment are undergoing a rapid transition from lab-based research experiments to devices with wide scientific and commercial viability [9]. Examples of such devices and their applications include atomic clocks for precision timekeeping [10–12], high-precision gravimeters and gravi-gradiometers for applications in geology, navigation and civil engineering [13–15], cold atom magnetometers [16, 17] and space-born fundamental experiments [6, 7].

For cold atom based quantum technologies, a UHV environment ($< 10^{-9}$ mbar) is required to ensure that the collision rate with background gas particles is low enough, to allow the formation of a cold atom cloud. Typically, UHV systems comprise standard off-the-shelf stainless steel components resulting in a large weight as well as multiple vacuum connectors and joints, leading to an increased likelihood of leaks occurring when subjected to temperature changes and mechanical stress.

In order to facilitate the production of portable devices for use in the field, a reduction in SWAP parameters (Size, Weight and Power consumption) and an increase in the robustness of the vacuum apparatus is highly desirable. For this, additive manufacturing offers unique solutions, because it enables the realisation of customised designs optimised for system performance and is not limited by manufacturing capabilities. Applying “design for
AM" [8] principles to UHV chambers facilitates low-mass and high-performance solutions featuring e.g. enhanced stability, consolidated parts or added functionality. In particular, the suitability of AM for the production of custom components with complex geometries and internal structures enables highly compact systems, reducing the number of separate components required and therefore eliminating the majority of vacuum joints. AM also offers the potential to enhance component performance for example by the inclusion of integrated, conformal fluidic channels, internal coil mounts, diaphragms, etc.

Although there are a few examples of AM materials being subject to an UHV environment [18–20], previous materials have not been characterised or assessed for use as a vacuum chamber. In the past, AM vacuum chamber performance has been limited to $>10^{-4}$ mbar, requiring specialised, custom sealing methods [20].

In this article we describe the design, construction and vacuum performance testing of the first additively manufactured UHV capable chamber. Produced via a metallic powder bed fusion technique (M-PBF), it has a mass of 245 g and offers a mass reduction of approximately 70% compared to conventional stainless steel chambers of similar size and functionality.

The vacuum chamber was designed for the functional requirements of a magneto-optical trap [21] (shown in Fig. 2a). These are: optical access for three orthogonal pairs of counter-propagating laser beams, magnetic coils, a UHV environment and the ability to connect to standard components, such as vacuum pumps.

A design for M-PBF methodology was applied to tailor the chamber for this application, reducing the overall weight without affecting the mechanical stability. The light-weighting of the chamber core was achieved via refinement of the port geometry and minimising the spacing between ports. A 2.5 mm thick internal skin was added between the ports to hold the UHV, as shown in Fig. 2b. Effort was made to keep symmetry where possible in the chamber design, in order to keep the ports perpendicular to the optical paths under the external pressure loading. The resulting (negligible) deformation of the chamber under an external pressure load was analysed via Finite Element Analysis (FEA) based simulation using MSc Marc 2017.1.0. Within a predefined volume (as shown in Fig. 2c) a variable density triply periodic minimal surface lattice was integrated with the symmetric internal core design to add a layer of robustness and increase stiffness; this took the form of a matrix based gyroid surface [22], as shown in Fig. 2d. The variable volume fraction (density) of the lattice permits reinforcement of areas which need more support, such as those adjacent to the ports. It also provides the added benefit of

FIG. 2. Overview of the design process. a, Illustration of the functional requirements for cold atom cloud trapping. b, Thin wall internal chamber design with conflat ports. c, Volume identified for additional lattice support. d, The variable density triply periodic minimal surface gyroid matrix lattice, which has been generated from the previous volume in c) to add a layer of robustness and increase structural stiffness. e, Final weight-optimised chamber design.
passive cooling of the chamber due to the increased external surface area-to-volume ratio. The final chamber design (Fig. 2e) consists of multiple conflat ports (2 × CF40 ports and 8 × CF16) making it compatible with standard UHV equipment, as shown in Fig. 3a. Building on the design approach demonstrated here, it will be possible to produce complex, multi-functional, part-consolidated chamber designs, which can only be realised by AM. Of the metallic alloys available for AM processing, aluminium alloy AlSi10Mg was selected for this application due to its high specific strength and low density [23]. Materials produced by M-PBF have a characteristically ultra-fine grain structure with epitaxial grain growth aligned with the build direction [24]. Solution heat treatments can be applied to homogenise the microstructure or control the grain size. Solution heat treatments are often utilised to increase the ductility of the alloy, subsequently an ageing heat treatment is applied to promote precipitate hardening and increase the material strength [25, 26]. The resulting material performance after the selected heat treatment regime was verified for knife edge seal repeatability and thread torque requirements. See methods for full details of the post-processing of the AM chamber following the build.

To assess the vacuum performance of the AM chamber, off-the-shelf stainless-steel viewports and tubes were mounted using standard CF flanges and the chamber assembled into a vacuum system, as shown schematically in Fig. 3a. Bake-out of the system was carried out for a period of 120 hours, during which the temperature did not exceed 120°C. Once baked, the assembly was pumped using a combined ion / non-evaporable getter (NEG) pump (NEXTorr D100-5, SAES Getters) and was found to achieve a pressure in the UHV range. The ion pump current reading indicates <$$10^{-10}$$ mbar, the lowest pressure that can be read via this method. The evolution of temperature and pressure during the bake-out phase is shown in Fig. 3b.

For a portable system, operation without external power supplies is highly desirable - therefore, the effect of turn-
ing off the ion pump for up to 48 hours was tested. During this time the chamber was pumped only via the passive NEG elements of the NEXTorr D100-5. When the ion pump was reactivated, the initial pressure was measured and its decay back to the under-range reading following ion pump activation was recorded. The results of these tests are shown in Fig. 3c. These tests demonstrate that the chamber can maintain pressures in the 10^{-10} mbar range for over two hours without active pumping and that even after 48 hours, the pressure remains in the 10^{-9} mbar range. The background pressure achieved was more than sufficient to permit the capture of a cloud of cold Rb atoms in a magneto-optical trap. Figure 1b shows a fluorescence image of the trapped atomic cloud.

M-PBF components and materials in general tend to have rough surfaces \[3\] and have therefore been thought unsuitable for UHV applications. In order to better understand the UHV performance of our AM chamber, we conducted a mass spectrometric study on the M-PBF material (10 \times 10 \times 4 mm cuboids), with the same post-processing treatment as the chamber, were placed in a temperature-controlled Knudsen Cell connected to a line-of-sight mass spectrometer. The molecular/atomic beam from the source can be interrupted by a rotating chopper, which allows the line of sight beam to be distinguished from background signals \[27\]. Scans were run across the mass range of 1 to 200 amu, while the material was heated up as far as 500°C with a heating rate of 10°C/min as shown in Fig. 4a. The experiment was then repeated in a quasi-stable situation keeping the sample for 48 hours respectively at 250°C, 350°C, 400°C and 450°C. In both cases similar behaviour was observed. Other than (expected and unavoidable) atmospheric species, the only peaks detected were for magnesium (primarily 24Mg), which became evident above 400°C. Below 375°C, no 24Mg signal is measurable, as determined by the noise level, while above that temperature a sharp rise in the magnesium signal is visible. If the temperature is raised above 400°C and then subsequently decreased, the 24Mg signal does not return to its original value, but remains at a considerably higher level (factor \(10^3\) at 350°C). The signal then persists at temperatures below 350°C.

We interpret these results as the removal of a protective layer, most likely magnesium hydroxide (melting point 350°C). The presence of the layer strongly reduces outgassing from the sample. This interpretation is supported by a second experiment, where samples were held at 420°C for 150 minutes and the time variation of the emission was measured (see Fig. 4b). All samples show a rapid initial reduction in Mg emission (fit 1 in Fig. 4b with a gradient of \(g_1 = -5.1(4) \exp(-3) \ln(\text{Torr})/\text{min}\)) followed by a much slower subsequent tail-off (fit 2 with a gradient of \(g_2 = -9.1(2) \exp(-4) \ln(\text{Torr})/\text{min}\)). The system was calibrated with a pure magnesium sample of the same dimensions as the M-PBF material and the observed count rate for the M-PBF samples was normalised to the magnesium counts and expressed as a partial pressure. Emission data taken immediately after the removal of the protective layer (i.e. in the regime of Fig. 4b, fit 1) can be plotted as an Arrhenius plot, resulting in a gradient proportional to the activation energy that corresponds within 1% to that of a pure magnesium sample. Therefore the behaviour seen in Fig. 4b is consistent with a relatively fast removal of an oxide layer leading to a thin exposed Mg-dominated layer at the sample surface. Removal of this Mg-layer (regime of fit 1) is followed by a regime where Mg emission is limited by diffusion of Mg from the bulk of the
Material to the surface layer (fit 2). A formation process for magnesium oxides at high temperatures during the M-PBF build process for AlSi10Mg has been suggested in [28, 29]. These results show that the material can be safely used at up to 350°C. For high temperature applications of additively manufactured parts (e.g. for use in scanning tunnelling microscopes) investigating methods to enhance the stability of this protective layer can be a promising line of investigation. In summary, we have demonstrated an additively manufactured vacuum chamber in the pressure range below $10^{-10}$ mbar and used it to trap a cold cloud of Rb atoms. Introducing AM methods to UHV vacuum chambers has a huge potential to increase compactness, reduce weight and material consumption of existing systems and enable new portable systems with inbuilt functionality. The results will impact on portable quantum sensors, quantum experiments in space applications and on the wider scientific and industrial community relying on complex vacuum systems.

**METHODS**

**Material**

The chemical composition of the pre-alloyed, gas atomised AlSi10Mg powder from TLS Technik GmbH, contains Al 89.8 wt%, Si 9.7 wt% and Mg 0.3 wt% with powder particles in the range 10 µm to 100 µm, measured using a Malvern UK Mastersizer 3000.

**Manufacture**

A Renishaw AM250 laser powder bed fusion machine was used to manufacture all test pieces and the final vacuum chamber. The machine uses a 200 W Yb fibre laser at 1064 nm wavelength and heats the powder bed to 180°C during build. The parts were built on an Aluminium baseplate using a powder layer thickness of 25 µm. A hatch spacing of 80 µm, point distance of 70 µm and exposure time of 220 µs were selected, giving an effective scanning speed of 318 mm s⁻¹. A chequerboard pattern was used to minimise the accumulation of residual stresses and after each layer, the scan pattern was rotated by 67 degrees.

**Post processing and mechanical machining**

Once processed and removed from the build machine, the parts were stress-relieve heat treated on the build plate for 2 hours at 300°C and furnace cooled. The parts were removed from the build plate by wire electro-discharge machining and bead blasted to remove any loosely adhered powder particles. Finally, a T6-like series of heat treatments were applied to modify the microstructure of the material [25]. The components were subject to a solution heat treatment for 1 hour at $\sim$ 500°C followed by a water quench and then aged for 6 hours at $\sim$ 150°C. To ensure a good tolerance at the mating surfaces between the chamber interfaces and the standard off-the-shelf UHV vacuum parts, the interfaces were machined, and knife edges and threaded bolt holes added. The internal chamber surface was left in the as-built condition.

**Knife edge tests**

The durability of the knife-edges machined in the AlSi10Mg M-PBF material was tested for repeated opening-closure cycles of a test flange. The performance of the seal was assessed using a leak detector (Pfeiffer Vacuum ASM 340). During all performed tests (up to 10 cycles) no measurable degradation of the seal was detected and confirmed the suitability of the selected post-processing heat treatment.

**Thread torque tests**

The performance of the threads machined into the blind holes was tested against the recommended bolt torque (9.5 Nm for M4, 16.3 Nm for M6 from Kurt J. Lesker) using standard stainless steel bolts within a similarly threaded test piece with M4 and M6 threaded holes. A torque wrench was used to apply the recommended bolt torque. No measurable degradation of the threads performance was determined during all tests (up to consecutive 10 repeats).

**Assembly**

The chamber was cleaned in three stages before assembly - first with water and detergent, then with acetone and finally with isopropanol. Following this the chamber was attached to standard conflat vacuum components using standard silver-plated copper gaskets. The bolts used to close the joins and compress the gaskets secure directly into the machined bolt holes in the chamber itself. M6 bolts, tightened with a torque of 16 Nm, were used for the CF40 fittings and M4 bolts, tightened with a torque of 9 Nm, for the CF16.

**Bake-out**

The assembled system was baked for 120 hours at a maximum temperature of 120°C. In order to avoid the possibility of over-ageing and softening the material around the knife edges, the bake-out temperature was kept well below the ageing temperature. During bake-out, a 300 l/s turbomolecular pump (Pfeiffer HiFace 300) was fitted via the angle valve shown in Fig. 3a.

**REFERENCES**


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